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on March 9, 2004 (Date of Deposit)
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Date Name

PATENT

Attorney Docket No.: 4097 P01
RW Ref. No.: APM/063-00



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Daniel J. HOFFMAN, et al.) Group Art Unit: 3742
)
Entitled: MERIE PLASMA REACTOR WITH) Examiner: Unknown
OVERHEAD RF ELECTRODE TUNED TO)
THE PLASMA WITH ARCING SUPPRESSION))
Serial No.: 10/007,367)
)
Filing Date: October 22, 2001)

REQUEST FOR STATUS OF APPLICATION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Inquiry is hereby made regarding the status of the above-identified patent application.

Applicants previously filed a Request for Status of Application on April 16, 2003 and subsequently received a communication from the USPTO dated May 7, 2003 indicating that the subject case would be examined in 2-5 months. Applicants' attorney has not as yet received an official action from the United States Patent and Trademark Office for the subject application which was filed on October 22, 2001. The address of applicants' attorney has not changed since this application was filed.

Kindly indicate to the applicants' attorney, the status of this application.

Respectfully submitted,



Dated: 03/09/2004

Robert M. Wallace
Attorney of Record 29,119

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